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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of: Walter SCHWARZENBACH et al.

Confirmation No. 9739

Application No.: 10/733,729

Group Art Unit: 2812

Filing Date: December 12, 2003

Examiner: D. Nhu

For: METHOD OF MAKING CAVITIES IN A  
SEMICONDUCTOR WAFER

Atty. Docket No.: 4717-9200

**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Sir:

This communication responds to the Office Action dated April 28, 2005,  
concerning the above-identified application.

**Amendments to the Specification** appear on page 2.

**Amendments to the Drawings** appear on page 3.

**Amendments to the claims** begin on page 4.

**Remarks** begin on page 8 of this paper.

No fee is believed due with this Amendment. Please charge any fee deemed  
necessary to Winston & Strawn LLP Deposit Account No. 50-1814.